XPER FLIM

The only system of choice for fluorescence lifetime imaging of both value and performance by NANO**BASE**





Time-Correlated Single Photon Counting

Fluorescence lifetime imaging microscopy or FLIM is an imaging instrument type for producing an image based on the differences in the exponential decay rate of the fluorescence from a fluorescent sample.

Fluorescence lifetime imaging yields images with the intensity of each pixel determined by τ , which allows researchers to view contrast between materials with different fluorescence decay rates, and also produces images which show changes in other decay pathways.

Fluorescence lifetimes can be determined in the time domain by using a pulsed source. When a population of fluorophores is excited by an ultrashort or delta pulse of light, the time-resolved fluorescence will decay exponentially.

Time-correlated single-photon counting (TCSPC) is usually employed as a measurement method because it compensates for variations in source intensity and single photon pulse amplitudes. More specifically, TCSPC records times at which individual photons are usually detected by a single photon avalanche photo diode (SPAD) with respect to the excitation laser pulse.

The recordings are repeated for multiple laser pulses and after enough recorded events, researchers are able to build a histogram of the number of events across all of these recorded time points. This histogram can then be fit to an exponential function that contains the exponential lifetime decay function of interest, and the lifetime parameter can accordingly be extracted.

Xper-FLIM is equipped with the single-photon avalanche diode (SPAD)-TCSPC FLIM system and can offer options of detection channels at lowcost, realizing super fast analysis for FLIM researchers. Xper-FLIM is also available in either an inverted microscope or an upright microscope to meet a recently growing number of various application needs.



Biology/Medical Research

Molecular biological analysisBiochemical analysis



Photoelectron Materials

Efficiency analysis of LED, OLED



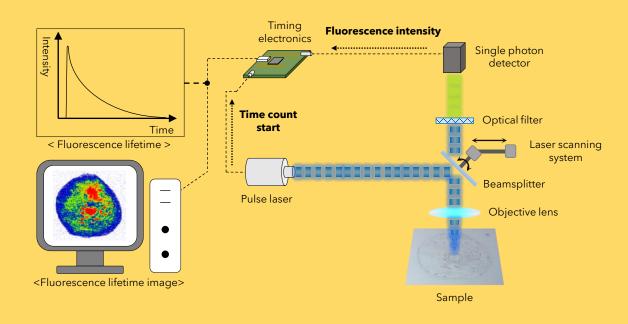
Semiconductors

Monitoring and analysis of wafer quality

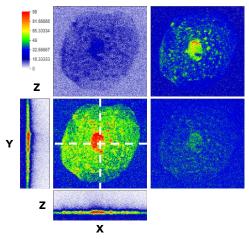


Solar Cells

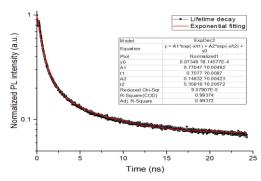
Efficiency analysis of injection



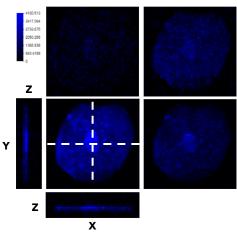
3-dimensional fluorescence intensity*



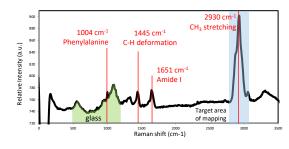
Lifetime decay of nucleus area*



Raman intensity mapping image*



Averaged Raman spectrum*



* Sample : Single oral epithelial cell

ORDERING INFO

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INFO	XperRF	 Functionalities : FLIm (TCSPC) analysis only Cat. No. : XPERRF Functionalities : FLIm (TCSPC) + Raman analysis 	
	Xper-FLIM	- Cat. No. : XPER-FLIM	
	NanoSpectrum Software Suite	 Fluorescence lifetime acquisition & imaging Spectrum data export format: .txt, .csv 2D mapping data export format: .spm, .csv 	Specifications are subject to change without notice.
	Electronics	Time-tagging electronics- Detection channels: 1 or 2- Time range: 25 ps- Trigger: 0~ -1200 mV- Count rate: 40 MHz- Marker: TTL x4	
	Laser Driver	 Repetition rate: 31.25 kHz ~ 80 MHz Trigger: Level -1 to +1 V (adjustable) Frequency range: 10 Hz ~ 80 MHz Synchronization output: Amplitude <0.8 mV into 50 Ohms 	
	Detector	Photon detection efficiency- 24 % at 400 nm- 49 % at 550 nm- 37 % at 650 nm- 37 % at 650 nm- Active area diameter : 50 μm- Dark counts: <250, <100, <50, <25 cps(depending on grade of detector)- NIM timing output: 50 ps- After-pulsing probability: <3%	
	System Platform	 1 slot to connect a laser neutral density (ND) filter or a polarizer 2 slots to connect polarizers or waveplates 1 slot to connect an interchangeable filter set Up to 3 lasers are installable. Fiber coupling port is installable. Provides a robust platform for stable beam alignment 	
	Optical Filter	Choose filters corresponding to laser wavelength - Wavelength range: 390 ~ 700 nm - Interchangeable in a filter box for corresponding lasers	
	Laser	<u>Picosecond pulsed diode laser and driver</u> - Wavelength: 390 ~ 700 nm - Freespace / Fiber coupling selection (optional)	
	Laser Scanning Module	 Wavelength range: 400~1000 nm Laser scanning mode: Raster scan Scanning area: 200 μm ×200 μm (when using a 40X objective lens) Includes a 6 MP camera for optical image acquisition (FOV: 220 μm × A controller is included (USB1.1) Maximum scan speed: >100 lines/s 	150 µm when using 40X)
	Microscope	 Mechanical X-Y stage with right-hand control Automatically controlled Z-axis position Includes main frame, stage plate, control box, interface cable, power of 40X objective (other options : 10X, 20X, 50X, and 100X) Upright or inverted microscope 	cable

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